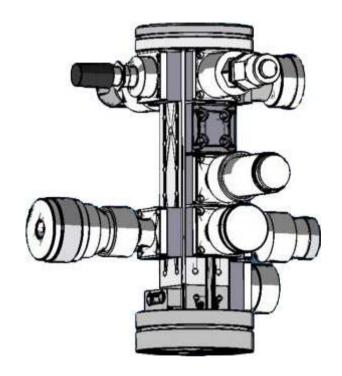


Online Analysis



Reliable innnovation





Our Approach

Permits the analyzer, along with the sample conditioning system and sensors, to be mounted at the sampling point of the process.

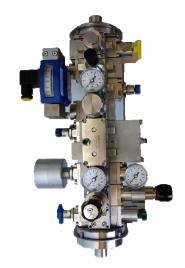
Continuous gas or liquid samples requiring pretreatment and conditioning prior to entering an analyzer.

The ASTUTE system permits the analyzer, along with the sample conditioning system and sensors, to be mounted directly on the fast loop of the sample system, nearest to the process.

For liquid samples ASTUTE can integrate a tangential filter (up to 0.2μ), an inline blowback system, and the appropriate treatment for the sample, be it coalescing filters, separators, etc.

For gas samples ASTUTE, installed in conjunction with a sample probe, a treatment column, or a CCIMS systems, can be installed directly on the process lines. Its infinite modularity permits any type of configuration for analysis and instru-mentation. ASTUTE is an excellent platform for the next generation of sensors and analyzers being developed for the ISA/ANSI SP76 specification. It allows for different sample streams, regulation of physical characteristics of the sample, and sample filtration all in one system.





Our commitments

Reliability

Minimized response time

Minimal maintenance

Reduction in the amount of sample sent to vent

Minimized congestion for a maximized accessibility

Complete modularity

Open system design with the ability to adapt to future needs

Proven track record

Economies of scale

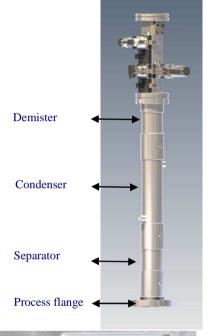
Reduction in the consumption of utilities



MOUNTING DIRECTLY ON A TREATMENT COLUMN ON THE PROCESS

- Complete pretreatment of the sample
- Modularity of the pretreatment system
- Connected directly to the process





- * Process Gas Measurements
- * CO2, O2, etc.
- * Process inerting control systems





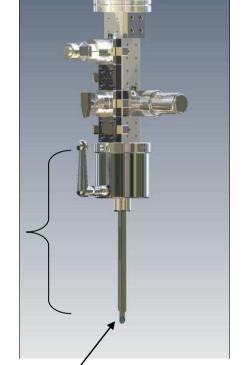
MOUNTING ON AN EXTRACTIVE PROBE

- Short response time
- Minimal dead volume
- Adapted for high pressure systems
- Internal fast loop



Sample probe

Pitot tube

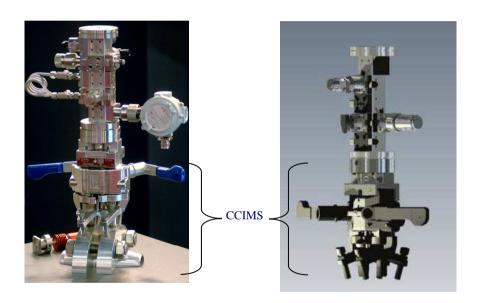


- * Process Gas Measurements
- * Moisture and H2S Measurements
- * BTU / GC... analysis.



MOUNTING ON THE PROCESS WITH A CCIMS

- Short response time
- Easily decoupled from the process line
- No bleed



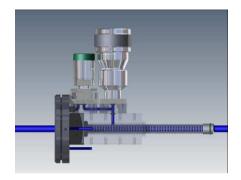
- Gas
- H₂O, H₂S, etc, analysis
- BTU / GC/ etc.





Mounting on a fast loop

- Integrated tangential filter
- Associated blowback system
- Compact system





- * Designed for liquid systems
- * Hydrocarbones
- * Sulfur analysis





Mounting box

- Decrease congestion
- Fast installation
- Easy maintenance





- * Gas / Liquid
- * O₂, CO, H₂O, H₂S,.. analysis
- * IRTF, Chromato,....



Functional components

Water fuse

SEC STPE Aqueous phase arrestor



Filter

SW UF Available in 2 and 3 ports configurations Filtration and coalescing applications Sheet#2122



Separator

SEC 12 UF Gas applications SEC 12 UF HV

Liquid/liquid Applications Sheet #2123



Filter SV UF

Available in 2 and 3 ports configuration Filtration and coalescing applications Sheet#2122



Separator

SEC 25 UF Gas applications SEC 25 UF HV Liquid/liquid applications



Filter

SV6600 Available in 2 and 3 ports configurations. Sintered stainless steel filter elements Sheet#2122



Blowback

HP 5 UF

Sheet #2124



FIB

Flow indicator, ball Sheet#2118



Eductor

ES1T UF

Sheet#2121



PG 13 Probe support

PG 13

Sheet#2128







Manual valves 2&3 way

Manual valve

Pneumatic diaphragm valve (low pressure)

Micrometre valve









Regulator

Needle valve

Check valve

Safety relief valve











Rmax Valve Single 3-way valve

Rmax Valve **Stream switching valves**

Permapure Fixed on 2 substrates







Page 10



Regulator DM 4000



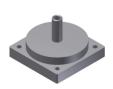
ATEX Heater

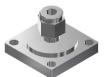


Heat exchanger Sheet #2131



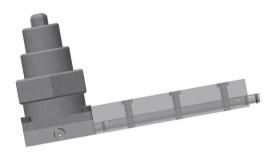
Adapters IF 4TA 1P OFFSET 045 IF 4A 1P SS







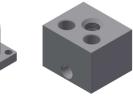
Vaporizing regulator 25 to 50 psig



Measuring probe support H₂O,O₂



IF 2F 1P SS IF 2F TOP SS







H2 measurement head space on a reactor



C3 measurement in hydrocarbon



Sampling with reactor include in ASTUTE 6 sides





Preconditionning system







Moisture measurement with ASTUTE in PVDF



Explosimetry measurement by IR



O2 measurement in VF2 by TDL





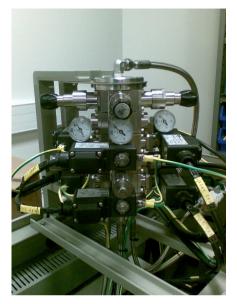
Adaptation Raman probe



Butadiene on GC

Moisture measurement by TDL





Sampler



CO2 measurement by PIR with fast loop

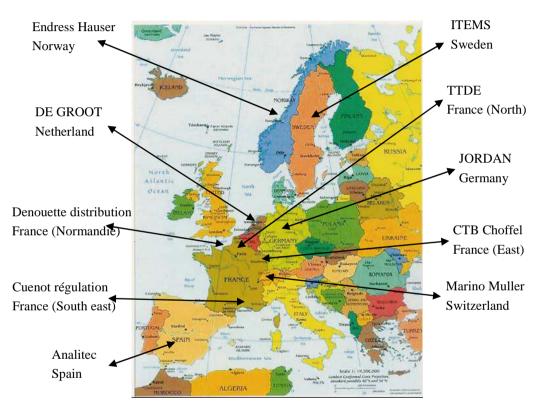


Laboratory test bench

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